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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of PCT/JP02/05786 06/11/2002 *KF*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2001-181955 06/15/2001

JAPAN 2001-192597 06/26/2001

JAPAN 2001-269880 09/06/2001

JAPAN 2001-270935 09/06/2001

JAPAN 2001-273078 09/10/2001

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 12	TOTAL CLAIMS 26	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>KF</i> Initials				

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## TITLE

Electron beam apparatus and a device manufacturing method by using said electron beam apparatus